

PATENT APPLICATION



IN THE U.S. PATENT AND TRADEMARK OFFICE

March 29, 2005

Applicant(s) : X. Shawn YU et al.

For : PANEL ARRANGEMENT

Serial No. : 10/730 617 Group: 3673

Confirmation No.: 4027

Filed : December 8, 2003 Examiner: Safavi

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International Filing Date : N/A

Atty. Docket No.: Haworth C-205D

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(4) and 1.98, enclosed herewith is Form PTO-1449 and the references cited thereon. Copies of cited U.S. references are not submitted in accordance with 37 CFR 1.98(a).

Further consideration is respectfully solicited.

Respectfully submitted,

Mark L. Maki

MLM/mag

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Encl: Form PTO-1449

INFORMATION
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U.S. PATENT DOCUMENTS

Examiner Initials	Document Number	Date	Name	Class	Sub Class	Filing Date
AA	4 433 630	02/1984	Laborie			
AB	5 301 477	4/1994	Rellinger et al.			
AC	6 021 613	2/2000	Reuter et al.			
AD	6 167 664	1/2001	Reuter et al.			
AE	6 367 213	4/2002	Reuter et al.			
AF						
AG						
AH						
AI						
AJ						
AK						

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	Translation Yes No
AL					
AM					
AN					
AO					
AP					

OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

AR	
AS	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.